

PATENT
PPER/PJS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

~~TRADE MARK~~
In application of:

Chen et al.

Serial No.: 10/032,284

Filed: December 21, 2001


For: Gas Delivery Apparatus and
Method for Atomic Layer
Deposition

Group Art Unit: Unknown

Examiner: Unknown

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

CERTIFICATE OF MAILING 37 C.F.R. 1.8	
I hereby certify that this correspondence is being deposited on February 12, 2002, with the U. S. Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.	
February 12, 2002	
Date	Signature

SECOND PRELIMINARY AMENDMENT

Prior to examination of the above referenced application, Applicants request that the application be amended as follows:

IN THE SPECIFICATION:

Please replace the paragraph [0001] with the following paragraph [0001]:

[0001] This application claims benefit of United States provisional Patent Application Serial Number 60/346,086, entitled "METHOD AND APPARATUS FOR ALD DEPOSITION," filed October 26, 2001, which is herein incorporated by reference.